



IPW

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Atsushi YAMAGUCHI

Group Art Unit: 2851

Application No.: 10/588,163

Examiner: P. KIM

Filed: August 1, 2006

Docket No.: 128939

For: EXPOSURE APPARATUS, EXPOSURE METHOD, POSITION CONTROL  
METHOD, AND METHOD FOR PRODUCING DEVICE

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the November 14, 2008 Office Action, please consider the following:

**Amendments to the Specification;**

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**